

Features

- · Stainless-steel cabinetry
- · Negative-pressure motor seal
- Non-contact ultra-pure N₂ heater
- Full-control facility panel
- Door-top DC ionizer
- · Full wrap-around bowl heater
- · PLC display with color touch screen

Benefits

- FM4910 compliance
- Much cleaner seal, reduced particles
- · Cleaner N₂
- · Precise control of flows and pressures
- Reduced particles
- Optimum drying performance
- · All components readily available



TRIDENT™ SRD

Spin Rinse Dryer Batch Processing Systems

Delivering advanced SRD performance for 75-200mm Substrates

The Trident™ family of spin rinse dryers (SRDs) from ClassOne Technology is all new equipment providing state-of-the-art technology in cleaning and rinsing wafers after wet processing — rapidly and efficiently removing residual chemicals and drying substrates completely without leaving water spots.

The system's non-contact heating results in cleaner nitrogen gas (N_2) because it places a filter after the heater and eliminates direct contact between N_2 and the heater. Trident SRDs also use ultra-pure valves and fittings throughout, and all systems include a comprehensive facility panel to precisely control all pressures and flows. These are typical of the design advances and efficiencies that give Trident its uniquely attractive performance-to-price value.

ClassOne's easy to use Trident SRD tools are available in bench-top, roll-around single-stack and dual-stack configurations, for processing up to 50 substrates per batch. The system accommodates 75mm to 200mm wafers, depending upon the model, chamber size and rotor used.

RIDENIT

Trident SRD Standard Specifications

- · Quick-disconnect rotor (single bolt)
- · Rotors included (customer selects size)
- · LCD color touch screen
- · Direct drive brushless motor
- · All stainless-steel cabinetry
- · Emergency power off (EPO), front and rear
- Foot-activated door-open switch
- · Deionized water recirculation saver
- · Resistivity monitor controller and probe
- Data logger
- Heater alarm
- · Over temperature protection
- · Ultra-pure Teflon pneumatic valves, pillar fittings
- Drain-trap connection
- · All stainless steel, easy-access panels
- · CE-certified

Options

- 50-wafer capacity bowl (to fit 2 cassettes)
- Substitute SS panel with FM4910 material
- Light tower with 3 indicator lamps R/Y/G
- · Rear display
- Bulk mount
- Extended warranty (2 years)

Models

- 75mm-150mm models
 - 2600: Single stack, tabletop model
- 4600: Single stack, roll-around model
- 8600: Dual stack
- 75mm-200mm models
 - 2800: Single stack, tabletop model
 - 4800: Single stack, roll-around model
 - 8800: Dual stack

Chamber Options

- Low profile chamber for 75-150mm substrates
- Low profile chamber for 75-200mm substrates
- · High profile chamber for 75-200mm substrates







